

**INFORMATION DISCLOSURE CITATION**  
(Use several sheets if necessary)

Docket Number (Optional)

FP03-023US

Application Number

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Applicant(s)

Hideto Nakamura et al.

Filing Date

Concurrently herewith

Group Art Unit

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**U.S. PATENT DOCUMENTS**

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
cfh		5,183,418	2-1993	Yamanashi et al.			
cfh		5,203,722	4-1993	Kinoshita			
cfh		5,439,397	8-1995	Yamanashi et al.			
cfh		5,569,055	10-1996	Yamanashi et al.			

**FOREIGN PATENT DOCUMENTS**

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO

**OTHER DOCUMENTS** (Including Author, Title, Date, Pertinent Pages, Etc.)


EXAMINER

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DATE CONSIDERED

12-15-04

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.